



# INSTYTUT TECHNOLOGII ELEKTRONOWEJ

Al. Lotników 32/46, 02-668 Warsaw, Poland

<http://www.ite.waw.pl>



**INNOWACYJNA  
GOSPODARKA**  
NARODOWA STRATEGIA SPÓJNOŚCI

**UNIA EUROPEJSKA**  
EUROPEJSKI FUNDUSZ  
ROZWOJU REGIONALNEGO



DKZ/60/2009

Warsaw, 13.08.2009

The Institute of Electron Technology informs that the close examination of the offers submitted in the course of the open tendering procedure for the **delivery of the system for dielectrics films deposition by sputtering technique** has led to the selection of the offer presented by **Kurt J. Lesker Company Ltd** which obtained the highest score.

The offers were submitted by the following companies:

No.	Name and address of the Contractor	Offer evaluation criteria	Scores
1.	Kurt J. Lesker Company Ltd 15/16 Burgess Road, Hastings East Sussex, TN 35	<ul style="list-style-type: none"><li>Price</li></ul>	<b>100,00</b>
2.	ALLIANCE CONCEPT 4, avenue du Pont-de-Tasset 74960 CRAN-GEVRIER	<ul style="list-style-type: none"><li>Price</li></ul>	<b>90,40</b>

Zbigniew Poznański

Deputy Director ITE

Director tel. +48 22 548 77 00; +48 22 843 30 93  
Deputy Director tel. +48 22 548 78 00  
Vice-Director for Research and Development tel. +48 22 548 77 60  
Vice-Director for Division of Silicon MNT, tel. +48 22 716 59 90  
Vice-Director for Division in Krakow tel. +48 12 656 51 83  
Chief Accounting Officer tel. +48 22 548 79 004 / 1140 1977 0000 5580 4500 1001

ISO 9001



Fax: +48 22 847 06 31  
NIP: 525-000-91-11

Bank Account:  
BRE Bank S.A., II Oddział Korporacyjny w Warszawie